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AMENDMENT TRANSMITTAL LETTER (Large Entity) Applicant(s): Hiroyuki Fukunaga OKI.616					
Application No. 10/761,223	Filing Date January 22, 2004	Examiner Brook Kebede	Customer I	No. Group Art Uni 2823	it Confirmation No. 2739
Invention: METHOD OF MANUFACTURING NONVOLATILE SEMICONDUCTOR STORAGE DEVICE					
COMMISSIONER FOR PATENTS: Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.					
CLAIMS AS AMENDED					
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	5 -	20 =	0	x \$50.00	\$0.00
NDEP. CLAIMS	2 -	3 =	0	x \$200.00	\$0.00
Multiple Dependent Claims (check if applicable)					
		TOTAL ADDITIONAL	FEE FOR THIS AM	ENDMENT	\$0.00
 No additional fee is required for amendment. □ Please charge Deposit Account No. in the amount of □ A check in the amount of to cover the filing fee is enclosed. ☑ The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0238 ☑ Any additional filing fees required under 37 C.F.R. 1.16. ☑ Any patent application processing fees under 37 CFR 1.17. □ Payment by credit card. Form PTO-2038. WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038. 					
Dated: August 15, 2006 Signature ANDREW J. TELESZ, JR.					
REG. NO. 33,581 VOLENTINE FRANCOS & WHITT, PLLC ONE FREEDOM SQUARE 11951 FREEDOM DRIVE, SUITE 1260 RESTON, VA 20190 TEL. NO. 571-283-0720			I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on (Date)		
oc:			Signature	e of Person Mailing Cor	respondence

Typed or Printed Name of Person Mailing Correspondence

Date: August 15, 2006

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Hiroyuki Fukunaga

Group Art Unit: 2823

Serial No.: 10/761,223

Examiner: Brook Kebede

Filed: January 22, 2004

Confirm No.: 2739

For:

METHOD OF MANUFACTURING NONVOLATILE SEMICONDUCTOR

STORAGE DEVICE

AMENDMENT UNDER 37 C.F.R. 1.116

U.S. Patent and Trademark Office Customer Window, **Mail Stop AF** Randolph Building 401 Dulany Street Alexandria, VA 22314

Sir:

In response to the Final Office Action dated May 17, 2006, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.